

<b>Notice of References Cited</b>	Application/Control No. 10/823,836		Applicant(s)/Patent Under Reexamination RAVI, KRAMADHATI V.	
	Examiner Patricia A. George		Art Unit 1765	Page 1 of 2

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,993,916	11-1999	Zhao et al.	427/535
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Choi; Electron energy distribution of diamond-coated field emitters; Journal of Vacuum Science and Technology B: Microelectronics and Nonameter Structures; 3/1998, Vol. 16, issue 2, pp. 716-719□□
	V	Sokolowska; The structure and mechanical properties of carbon layers formed by crystallization from pulse plasma; Journal of material Science 21 (1986) 763-767)
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	X	Ristein; Elsevier Science S.A.; 2000; Diamond and Related Materials 9 1129-1137; Electronic properties of diamond surfaces - blessing or curse for devices?

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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	Examiner Patricia A. George	Art Unit 1765	Page 2 of 2

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	U	Blandino; Application of Diamond Films to Electric Propulsion: Low Energy Sputter Yield Measurement and MPD Plasma Assisted Chemical vapor Deposition; California Institute of Technology; April, 2001
	V	The Allotropes of Carbon; Carbon Bonding; <a href="http://invsee.asu.edu/nmodules/Carbonmod/bonding.html">http://invsee.asu.edu/nmodules/Carbonmod/bonding.html</a>
	W	Catledge et al.; High density plasma processing of nanostructured diamond films on metals; Journal of Applied Physics, Vol. 84, No. 11; Dec. 1998
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